



PATENT
Attorney Docket No. 01-099
Express Mail Label No. EV249895883US

3/4
7/10/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Rongxiang Hu, Philippe Schoenborn,))
and Masaichi Eda))
Serial No. 09/928,570))
Filed: August 13, 2001))
For: HIGH SELECTIVELY SiC ETCH))
IN INTEGRATED CIRCUIT))
FABRICATION))

Group Art Unit: 1765
Confirmation No. 7873
Examiner: L. Umez-Eronini

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AMENDMENT AND RESPONSE TO FIRST OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed March 31, 2003, please amend the application as set forth below in the Two Parts of this Amendment and Response.

IN THE CLAIMS:

Amend claims 1-6 and 8-11.

Part 1 hereof presents the claims with markings to indicate the changes.

REMARKS

Part 2 comments on the above amendments, and the March 31, 2003 office action.